

**For website and circulation**

**Advertisement for JRF position in ISRO funded project**

**Project Title:** Active Radar Absorbers based on Frequency Selective Surface: Active Stealth Technology.

Applications are invited for the post of Junior Research Fellow at a fixed fellowship amount of Rs. 25,000/ plus HRA@16% (if hostel accommodation is not provided) in DRDO sponsored project entitled Active Radar Absorbers based on Frequency Selective Surface: Active Stealth Technology. The candidates should have M.Tech./M.E.in Electronics and Communication Engineering with minimum 60% marks. However, GATE qualification is desirable. The prior knowledge of CST Microwave Studio and MATLAB software are desirable. The upper age limit is 28 years (relaxable by 5 years for SC/ST/Physically Handicapped/Female candidates). Candidates desirable of applying for the said position may send their latest CV giving name, permanent and correspondence address, names of father and mother, telephone no., and email address, details of educational career (starting from High School or equivalent) along with self-attested copies of all marks-sheets & certificates and details of any research or relevant experience etc, if any. This information should reach within 15 days from the date of this advertisement to Dr. Kumud Ranjan Jha, Associate Professor, School of Electronics and Communication Engineering, SMVD University, Katra, J&K via email to [kumud.ranjan@smvdu.ac.in](mailto:kumud.ranjan@smvdu.ac.in).

Duration: Initial appointment will be for 12 months, which is extendable up to the duration of the project solely based on performance. The above position is purely on contractual basis and co-terminus with the project. Applications shall be scrutinized on the basis of qualification, experience and suitability of the candidate to the work. Only shortlisted candidates after the initial screening shall be called for Interview. List of eligible candidates shortlisted for the interview shall be intimated by e-mail ONLY. No TA/DA will be paid for attending the interview.

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